Atty. Docket No. PIA31180/DBE/US

Serial No: 10/750,248

## Claims

Please amend the claims as follows:

- 1-8. (Withdrawn)
- 9. (Currently amended) A method for removing polymers generated during etching processes, comprising the steps of:

removing the polymers by using an inorganic compound including DIW, H2SO4, H<sub>2</sub>O<sub>2</sub> and HF;

forming a protective oxide film on a metal line, a via hole or a pad open area by using H2O2; and

protecting the metal line, the via hole or the pad open area by the protective oxide film while removing the polymers by using HF,

wherein DIW occupies by volume about 70.5% to about 80.5% of the total volume of DIW, H-SO4, H-O2 and HF, H-SO4 occupies by volume about 6.5% to about 8.5% of the total volume of DIW, H-SO4, H-O2 and HF, H-O2 occupies by volume about 15% to about 19% of the total volume of DIW, H2SQ4, H2Q2 and HF, and HF occupies by volume about 50 PPM to about 150 PPM of the total volume of DIW, H-SO4, H-O2 and HF, and wherein the total volume % of DIW, H2SO4, H2O2 and HF is about 100 %.

- 10. (Canceled)
- 11. (Currently amended) The method of claim [[10]] 9, wherein DIW occupies by volume about 75.5% of the total volume of DIW, H2SO4, H2O2 and HF.
  - 12. (Canceled)

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- 13. (Currently amended) The method of claim [[12]] 9, wherein H<sub>2</sub>SO<sub>4</sub> occupies by volume about 7.5% of the total volume of DIW, H<sub>2</sub>SO<sub>4</sub>, H<sub>2</sub>O<sub>2</sub> and HF.
  - 14. (Canceled)
- 15. (Currently amended) The method of claim [[14]] 9, wherein H<sub>2</sub>O<sub>2</sub> occupies by volume about 17% of the total volume of DIW, H<sub>2</sub>SO<sub>4</sub>, H<sub>2</sub>O<sub>2</sub> and HF.
  - 16. (Canceled)
  - 17. (Withdrawn)